



0321.70917

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: James R. Link
Serial No.: 10/567,917
Conf. No.: 5897
Filed: February 6, 2006
For: PHOTONIC SENSOR PARTICLES
AND FABRICATION METHODS
Art Unit: 1763
Examiner: Unassigned

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Aug, 30, 2006
Date

Arik B. R.
Registration No. 43,874
Attorney for Applicant(s)

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This IDS is submitted under 37 C.F.R. §1.97(b) within any of the following time periods, whichever occurs last:

- (a) within three months of either the filing date of the application or the date of entry into the national stage; or
- (b) before the mailing date of First Office Action on the merits (i.e., not including actions such as restriction requirements); or
- (c) before the mailing of a First Office Action after the filing of a Request for Continuing Examination.

Applicant(s) submit herewith Form PTO-1449 (Information Disclosure Citation) together with copies of foreign patents, publications or other information of which applicant(s) are aware, which applicant(s) believe may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 C.F.R. §1.56. Applicant(s) respectfully submit that the citation of any reference on Form PTO-1449 does not constitute an admission that the reference qualifies as prior art.

It is requested that the information disclosed on the enclosed Form PTO-1449 be made of record in this application.

The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R. §§1.16-1.17, or to credit any overpayment, to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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By: Arik B. R.
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Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/567,917
				Filing Date	February 6, 2006
				First Named Inventor	James R. Link
				Art Unit	1763
				Examiner Name	Unassigned
Sheet	2	of	5	Attorney Docket Number	0321.70917

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²	
		Y. Xia, J.A. Rogers, K.E. Paul, G. Whitesides, "Unconventional Methods for Fabricating and Patterning Nanostructures", Chem. Rev., 1999, Vol. 99, pp. 1823-48		
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		B. Warneke, M. Last, B. Liebowitz, K.S.J. Pister, "Smart Dust: Communicating with a Cubic Millimeter Computer," IEEE Computer Society, Vol. 34, No. 1, January 2001, pp. 44-51	
		Y.Y. Li, F. Cunin, J.R. Link, T. Gao, R.E. Betts, S.H. Reiver, V. Chin, S.N. Bhatia, M.J. Sailor, "Polymer Replicas of Photonic Porous Silicon for Sensing and Drug Delivery Applications," Science, Vol. 299, March 28, 2003, pp 2045-47	
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